



EFW

**PATENT APPLICATION**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re application of

Docket No: Q81015

Shuho MOTOMURA

Appln. No.: 10/820,752

Group Art Unit: 1762

Confirmation No.: 8798

Examiner: Katherine A. Bareford

Filed: April 9, 2004

For: SUBSTRATE PROCESSING SYSTEM, COATING APPARATUS, AND COATING METHOD

**AMENDMENT UNDER 37 C.F.R. § 1.111**

**MAIL STOP AMENDMENT**

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated May 24, 2006, please amend the above-identified application as follows on the accompanying pages.